## PATENT APPLICATION

		413/13
In re Application of:	)	7/.7
	:	Examiner: D. Florez Ruiz
TADAHIRO OHMI, ET AL.	)	(3460)
	:	Group Art Unit: 2828
Application No.: 09/494,945	)	

Filed: February 1, 2000

For: LASER OSCILLATING APPARATUS, ) EXPOSURE APPARATUS USING THE SAME, AND DEVICE

January 7, 2003 FABRICATION METHOD

Commissioner for Patents Washington, D.C. 20231

## SUPPLEMENTAL AMENDMENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Sir:

Further to the Amendment timely filed on December 2, 2002, please amend the above-identified application as follows.

## IN THE CLAIMS:

Please cancel Claims 100-107, without prejudice to or disclaimer of the subject matter recited therein.